



#17/election
6-18-02
JD

Docket No.: 50432-022

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
:
Lu YOU, et al. :
:
Serial No.: 09/785,445 : Group Art Unit: 2811
:
Filed: February 20, 2001 : Examiner: H.K. Vu
:
For: SINGLE DAMASCENE INTEGRATION SCHEME FOR PREVENTING COPPER
CONTAMINATION OF DIELECTRIC LAYER

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
Washington, DC 20231

Sir:

Noting the Office Action of June 4, 2002 wherein restriction has been required, Applicants hereby elect Group 1 (claims 1 through 18) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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